

030RR

See Catalog 500 for detailed pattern.

規格(1)	in	mm
Gage Length	0.030 <i>ES</i>	0.76 <i>ES</i>
Grid Centerline Diameter	0.170	4.32
適合的鑽頭尺寸(Min.)	0.090	2.3
適合的鑽頭尺寸 (Max.)	0.100	2.5
Matrix Length	0.37	9.4
Matrix Width	0.37	9.4

Gage Designation (2)	Resistance (3)	Options (4)
N2K-XX-030RR-350/DP	350 ±0.4%	



031RE

See Catalog 500 for detailed pattern.

<b>Gage Length</b>	0.031 <i>ES</i>	0.79 <i>ES</i>
Grid Centerline Diameter	0.101	2.56
適合的鑽頭尺寸(Min.)	0.03	0.8
適合的鑽頭尺寸 (Max.)	0.04	1.0
<b>Matrix Length</b>	0.29	7.4
<b>Matrix Width</b>	0.29	7.4

<b>Gage Designation</b> (2)	<b>Resistance</b> (3)	<b>Options</b>
EA-XX-031RE-120	120 ±0.2%	
EA-XX-031RE-120	120 ±0.4%	<b>SE</b>



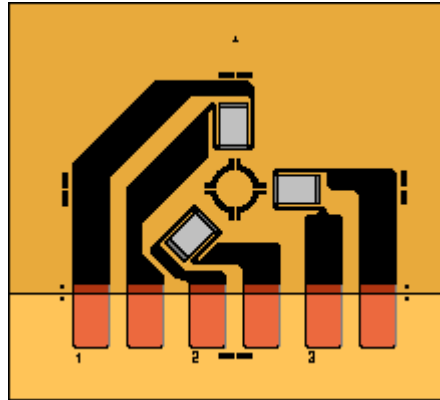
062RE

See Catalog 500 for detailed pattern.

規格(1)	in	mm
<b>Gage Length</b>	0.062 <i>ES</i>	1.57 <i>ES</i>
Grid Centerline Diameter	0.202	5.13
適合的鑽頭尺寸(Min.)	0.06	1.5
適合的鑽頭尺寸 (Max.)	0.08	2.0
<b>Matrix Length</b>	0.42	10.7
<b>Matrix Width</b>	0.42	10.7

**Gage Designation (2) Resistance (3) Options**

EA-XX-062RE-120	120 ±0.2%	
EA-XX-062RE-120	120 ±0.4%	SE



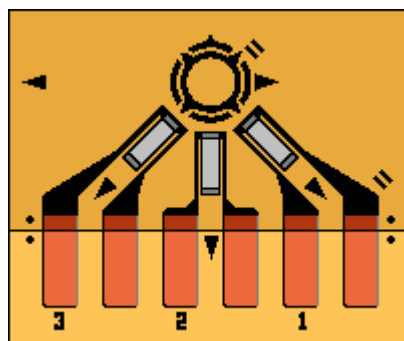
062UL

See Catalog 500 for detailed pattern.

規格(1)	in	mm
Gage Length	0.062 ES	1.57 ES
Grid Centerline Diameter	0.202	5.13
適合的鑽頭尺寸(Min.)	0.06	1.5
適合的鑽頭尺寸 (Max.)	0.08	2.0
Matrix Length	0.50	12.7
Matrix Width	0.62	15.7

**Gage Designation (2) Resistance (3) Options (4)**

CEA-XX-062UL-120	120 ±0.4%
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062UM

See Catalog 500 for detailed pattern.

規格 (1)	in	mm
Gage Length	0.062 <i>ES</i>	1.57 <i>ES</i>
Grid Centerline Diameter	0.202	5.13
適合的鑽頭尺寸 (Min.)	0.06	1.5
適合的鑽頭尺寸 (Max.)	0.08	2.0
Matrix Length	0.38	9.6
Matrix Width	0.48	12.2

Gage Designation (2)	Resistance (3)	Options (4)
CEA-XX-062UM-120	120 ±0.4%	



125RE

See Catalog 500 for detailed pattern.

規格 (1)	in	mm
Gage Length	0.125 <i>ES</i>	3.18 <i>ES</i>
Grid Centerline Diameter	0.404	10.26
適合的鑽頭尺寸 (Min.)	0.12	3.0
適合的鑽頭尺寸 (Max.)	0.16	4.1
Matrix Length	0.78	19.8
Matrix Width	0.78	19.8

Gage Designation (2)	Resistance (3)	Options
EA-XX-125RE-120	120 ±0.2%	
EA-XX-125RE-120	120 ±0.4%	SE